

Docket No.: 4590-500

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	
	:	
Elias BITAR et al.	:	Confirmation No. 4104
	:	
U.S. Patent Application No. 10/577,063	:	Group Art Unit: 2624
	:	
Filed: April 24, 2006	:	Examiner: Stephen R. KOZIOL

For: METHOD FOR DETERMINING OPTIMAL CHAMFER MASK COEFFICIENTS FOR
DISTANCE TRANSFORM

AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated September 11, 2008, a reply being due Feb. 11, 2009 with a two month extension of time, please amend the above-identified application as follows:

Amendments to the Claims – page 2

Remarks/Arguments – page 7